Docket No.: 60188-783 **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277

Etsuyoshi KOBORI : Confirmation Number:

Serial No.: : Group Art Unit:

Filed: February 20, 2004 : Examiner:

For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

## **INFORMATION DISCLOSURE STATEMENT**

Mail Stop IDS Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the document listed on the attached form PTO-1449. It is respectfully requested that the document be expressly considered during the prosecution of this application, and that the document be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The relevance of Japanese Unexamined Patent Publication No. 2001-176959, is discussed in the present specification.

## Serial, No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Fogarty Registration No. 36,139

600 13<sup>th</sup> Street, N.W. Washington, DC 20005-3096 (202) 756-8000 MEF:gav Facsimile: (202) 756-8087

Date: February 20, 2004

SHEET	1	OF	
DITLE	1.	OI.	

							SHEE.	<u> </u>	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (PTO-1449)				ATTY. DOCKET NO. SERIAL NO.					
				APPLICANT Etsuyoshi KOBORI					
				FILING DATE February 20, 2004		OUP			
. 4.		r 5	28 · 1 · 2	U.S. PATE	NT DOCUMENTS	, 4			
EXAMINER'S INITIALS	CITE NO.	Num	Document Number ber-Kind Code2 (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Appl Occument	Name of Patentee or Applicant of Cited Document Pages, Colum Relevant Pass Figure		s or Relevant	
		US							
		US							
		US							
		US				*100			
		US							
		US				.,,,			
		US							
		US							
		US		1					
		US				<del></del>			
		US							
		US						··-·	
391-3-432-3-43		à à	A Commence	FOREIGN P	ATENT DOCUMENTS				
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Publication CITE Country Codes - Number 4 - Kind MM-DD-		Publication Date MM-DD-YYYY				Translation	
	<del>                                     </del>		JP 2001-176959 A	06/29/2001	MITSUBISHI ELECTRIC	<u> </u>	Yes JAPAN (w/English	No	
				00/20/2001	CORP		Abstract)		
			<del> </del>						
					-	ļ			
4 3 4	<u> </u>	W - 15	OTHER A	 RT*(Including*Autt	I hor,⁵Title, Date, Pertinent Pages, E	 Fic.)> → → → →		1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1	
EXAMINER'S INITIALS	CITE NO.	journ	de name of the author (in	CAPITAL LETTER	RS), title of the article (when approage(s), volume-issue number(s), p	priate), title of t	he item (book, magazine		
	ļ								
- FYANINGS						DATE 00:10:1			
EXAMINER					DATE CONSIDERED				

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.